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Docket No.: M4065.0319/P319
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ronald A. Weimer, et al.

Application No.: 09/296,835

Group Art Unit: 2813

Filed: April 22, 1999

Examiner: E. Kielin

For: FABRICATION OF DRAM AND OTHER
SEMICONDUCTOR DEVICES WITH AN
INSULATING FILM USING A WET
RAPID THERMAL OXIDATION PROCESS

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SEP 28 2001
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REQUEST FOR CORRECTED FILING RECEIPT

Office of Initial Patent Examination Customer Service Center
Commissioner for Patents
Washington, DC 20231

Dear Sir:

Applicant hereby requests that a corrected Filing Receipt be issued in the above-identified patent application. The official Filing Receipt received by Applicant, a copy of which is attached hereto, has the following error:

Under Atty. Docket No.: "07653/025001" should read
"M4065.0319/P319".

Applicant additionally requests that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Dated: September 19, 2001

Respectfully submitted,

By 

Thomas J. D'Amico

Registration No.: 28,371

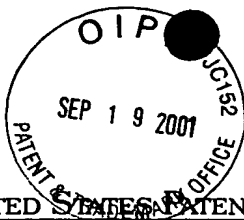
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UNITED STATES PATENT AND TRADEMARK OFFICE

M4065.0319/P319

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 UNITED STATES PATENT AND TRADEMARK OFFICE
 WASHINGTON, D.C. 20231
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/296,835	04/22/1999	2813	1872	07653/025004	8	40	5

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CONFIRMATION NO. 8895
 CORRECTED FILING RECEIPT



Date Mailed: 09/05/2001

Receipt is acknowledged of a CPA in this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

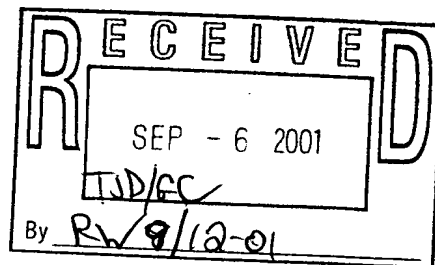
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Domestic Priority data as claimed by applicant**Foreign Applications****If Required, Foreign Filing License Granted 05/11/1999****CPA filed on: 08/08/2001****Projected Publication Date: 12/13/2001****Non-Publication Request: No****Early Publication Request: No****Title**

FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING
 FILM USING A WET RAPID THERMAL OXIDATION PROCESS

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Preliminary Class

438

Data entry by : VANNAL, VANESSA

Team : 2800

Date: 09/05/2001





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Bib Data Sheet

CONFIRMATION NO. 8895

SERIAL NUMBER 09/296,835	FILING DATE 04/22/1999 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. M4065.0319/P319
APPLICANTS RONALD A. WEIMER, BOISE, ID; SCOTT J. DEBOER, BOISE, ID; DAN GEALY, KUNA, ID; HUSAM N. AL-SHAREEF, MURAIJEB AL-AIN, UNITED ARAB EMIRATES;				
** CONTINUING DATA ***** <i>EK (none)</i>				
** FOREIGN APPLICATIONS ***** <i>EK (none)</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/11/1999				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <i>Allowance</i> Verified and <i>EK</i> Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		STATE OR COUNTRY ID	SHEETS DRAWING 8	TOTAL CLAIMS 40
			INDEPENDENT CLAIMS 5	
ADDRESS THOMAS J. D'AMICO, ESQ. DICKSTEIN, SHAPIRO, MORIN & OSHINSKY, LLP 2101 L STREET, N.W. WASHINGTON, DC 20037				
TITLE FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS				
FILING FEE RECEIVED 1872	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	